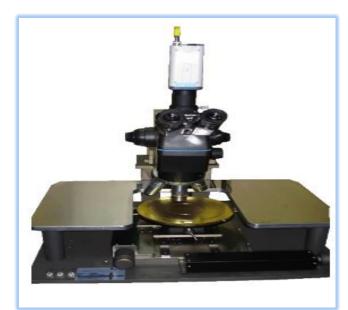


APS150 | 150 mm Manual Analytical Probe Station For True DC/CV and RF measurements

FEATURES / BENEFITS

- ♣ Manual stage assembly with up to 170mm x 170mm range of motion
- ♣ Powder-coated steel platen holds up to 10 magnetic or vacuumbased positioners.
- ♣ High quality stereo zoom/compound microscopes with high-intensity LED lighting provide outstanding vision at magnifications. Includes camera port



- ♣ Standard boom mount assembly for full-range XYZ positioning of microscope. XY range of 15mm x15mm (higher range available).

 Bridge mounted scopes are also available on customers request.
- **4** Available high resolution micropositioners
- ♣ RF options available (Up to 67 GHz) include customizable RF probes, RF bias-able chuck, and shielding enclosures

SPECIFICATIONS

Chuck XYZ Stage Travel:

Total travel range	: Up to 170 mm x 170 mm
Travel resolution	: < 1.0 μm
Planarity	: $\leq 10 \mu m$, Optional available on request
Chuck Z axis adjustment	: 10 mm
Chuck Theta travel	: ±360°
Chuck Pull Out Stage	: 90 mm pull out Stage





PLATEN:

Specifications:

Material : Stainless Steel

Chuck to platen height : Min. 10 mm

Platen lift control : Fixed, Platen lift of up 25 mm available on

request(Optional)

Max. No of Micro-Positioners : Up to 6 DC and 4 RF Positioners

Micropositioners Mounting : Compatible for both Magnetic as well as Vacuum

base micropositioners

RF Micro-Positioner mounting : Magnetic/Vacuum base with guided rail

DC Micro-Positioner mounting : Magnetic/Vacuum base

4 NON-THERMAL CHUCKS

Standard Wafer Chuck:

Chuck Connections : Coaxial(BNC)/ Triaxial

Chuck Diameter : Up to 150 mm

Chuck Material : Stainless Steel. Chuck made of other material is

available as optional

Chuck surface : Planar with centric engraved vacuum grooves

Chuck Sample actuation : Vacuum actuation with three zone vacuum holes

Sample Size : Min 5mm x 5mm up to 150 mm wafer

Chuck Surface Planarity : $10\mu m$, Optional down to $\pm 3\mu m$

RF Wafer Chuck:

Chuck Connections : Coaxial(BNC)

Chuck Diameter : Up to 150 mm 2 AUX chuck as optional

Chuck Material : Nickel Plated aluminum, Ceramic etc

Chuck surface : Planar with centric engraved vacuum grooves

Chuck Sample actuation : Vacuum actuation with three zone vacuum holes

Sample Size : Min 5mm x 5mm up to 150 mm wafer

Chuck Surface Planarity : $10\mu m$, Optional down to $\pm 3\mu m$





Auxiliary Chuck:

Quantity : 2 Nos of AUX Chuck

Chuck Diameter : Up to 150 mm

Chuck Material : Derlin, Ceramic, RF absorbing material

Chuck Sample actuation : Separate vacuum control switches for auxiliary

chucks

Sample Size : Min 5mm x 5mm up to 150 mm wafer

Chuck Surface Planarity : $10\mu m$, Optional down to $\pm 3\mu m$

4 ELECTRICAL SPECIFICATIONS:

Power Handling of Chuck:

Maximum voltage: 3,000 V (triax and coax) (Thermal Chuck: capable of 3 kV @ 200°C and 2.5 $\,$

kV @ 300°C)

Maximum current: 40 A (pulsed), 2 A (DC)

Standard Chuck @10 V:

Parameter	Coaxial Chuck	Triaxial Chuck
Maximum voltage between chuck and	500 V DC	500 V DC
GND		
Isolation	$> 2 G\Omega$	
		Force to guard $> 25T\Omega$
		Guard to shield > 3T
		Force to shield $> 500G\Omega$
Leakage current	< 50pA	≤ 50fA
Capacitance	< 800pF	< 100fF
Chuck Flatness	≤10µm	≤10µm

4 THERMAL CHUCK:

Parameter	Coaxial Chuck	Triaxial Chuck
Temperature Control	Resistive type heating	Resistive type heating
Method		
Cooling	Air cooling/Water cooling	Air cooling/Water cooling
Temperature Range	RT - 200°C, Optional up to 600°C	RT - 200°C, Optional up to 600°C
Temperature Control	Linear DC/PID	Linear DC/PID
Temperature Sensor	(RTD) Pt100//3DIN, 4-line wired	(RTD) Pt100//3DIN, 4-line wired
Temperature Stability	±0.5 °C	±0.5 °C
Temperature Accuracy	±1 °C	±1 °C





Connection Interface	RS232	RS232
Chuck Surface Plating	Nickel/Gold	Nickel/Gold
Surface Flatness	$\pm 10 \mu m@RT \& \le 30 \mu m@ \ge 300^{\circ}$	$\pm 10 \mu m@RT \& \le 30 \mu m@ \ge 300^{\circ}C$
Leakage Current	< 100pA	<100fA

Micropositioners:

Model	Descri	ption
MH100	Fixed Magnet Base Switchable Magnet Base Vacuum Base	
MH100	Foot dimension Travel range X,Y Travel range Z Feature Resolution TPI resolution	70 x 50mm 12mm 8mm 1µm/0.8µm 80 TPI/100TPI
MH300	Fixed Magnet Base Switchable Magnet Base Vacuum Base	
MH300	Foot dimension Travel range X,Y Travel range Z Feature Resolution	70 x 35mm 12mm 12mm 3µm
MH500	Switchable magnet base Vacuum Base	
MH500	Foot dimension Travel range X, Y Travel range Z Feature Resolution	80 x 90mm ±15 mm ±15 mm 3μm

♣ Probe Tip Holders with Connecting Cable:

Model	Description	
Coaxial Tip Holder with Coaxial Cable		
SHC15	Spring Holder/1.5m coax cable/BNC male	
THC15	Tube Holder/1.5m coax cable/BNC male	
NHC15	Nut Holder/1.5m coax cable/BNC male	
Triaxial Tip Holder with Triaxial Cable		
THT15	Tube Holder/1.5m Triax cable/Triax male	
NHT15	Nut Holder/1.5m Triax cable/Triax male	
High Frequency Probe Arms		
MWA-EW	HF probe arm (east-west)	
MWA-NS	HF probe arm(north - south)	
System Dimensions: 580mm wide x460mm deep x 245mm high		

Weight: 42kg to 50kg depending on options selected